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862.C2032

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: NYA
HIROSHI TSUJI ET AL.)	
	:	Group Art Unit: NYA
Application No.: NYA)	
	:	
Filed: Herewith)	
	:	
For: ELECTRON BEAM)	
LITHOGRAPHY APPARATUS	:	October 18, 2000

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 09/691234
 U.S. PTO
 1483CJ

The Assistant Commissioner of Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

RECEIVED
 MAR 20 2001
 TC 2800 MAIL ROOM

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents identified on the enclosed Form PTO-1449. Copies of the documents are also enclosed.

For the concise statement of relevance for the non-English documents the Examiner is referred to the abstracts attached thereto.

It is respectfully requested that the above information be considered by the Examiner and that a copy of

the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our below listed address.

Respectfully submitted,

Z. P. Dianna
Attorney for Applicants

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